	Application No.	Applicant(s)	
Aladia af Allawahilita	10/796,999	IRINO, HITOSHI	
Notice of Allowability	Examiner	Art Unit	
	Lee, Calvin	2818	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. X This communication is responsive to Election dated 9/02/0	<u>5</u> .		
2. The allowed claim(s) is/are <u>1-41</u> .			
3. A The drawings filed on 11 March 2004 are accepted by the Examiner.			
4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b)			
Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).			
7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
	6. Interview Summary Paper No./Mail Dat 8), 7. Examiner's Amendm 8. Examiner's Stateme 9. Other	e	
Supervisory Patent Examiner Technology Center 2800			

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Docket: 045054-0158 IRINO et al.

OFFICE ACTION

Examiner's Amendment

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312.

<u>IN THE CLAIMS</u>: Canceled claims 17-25 and 42-56, which were non-elected (without traverse) dated September 2, 2005.

Allowable Subject Matter

2. Claims 1-16 and 26-41 are allowed. Following is the reason for allowance:

The closest art, US 5,702,972 to *Tsai et al*, discloses second regions 24 having second surface regions (i.e., the regions underneath the spacers 20, 22 in Fig. 3) that sandwich a first surface region (i.e., the channel region) and are not covered with silicide layers 30 [Fig. 6 and col. 3]. *Tsai et al* teaches, "the resistance of C54-TiSi₂ is lower than that of the C₄₉ phase" [col. 6, ln.50]. *Tsai et al* is silent about silicide layers make up a low resistance region having a relatively low resistance value, second surface regions makes up an intermediate resistance region having an intermediate resistance value, and a first surface region makes up a high resistance region having a relatively high resistance value.

3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance.

Contact Information

4. Any inquiry concerning this communication from the Examiner should be directed to *Calvin Lee* at (571) 272-1896 from 7:00AM to 5:00PM (Monday-Thursday, Eastern Time). If attempts to reach the examiner by telephone are unsuccessful, Art Unit 2825's Supervisory Patent Examiner *David C. Nelms* can be reached at (571) 272-1787.

Any inquiry relating to the status of this application should be directed to the Group receptionist whose telephone number is (703) 308-0596. The central fax number is (571) 273-8300 for all communications to be entered (e.g., amendments, remarks, IDS, etc.)

Dated: October 13, 2005

Bavid Nelms
Supervisory Patent Examiner
Technology Center 2800